

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Katsuya HASEGAWA et al.
Title: METHOD OF FORMING THIN
FILM ON BASE SUBSTANCE
VIA INTERMEDIATE LAYER
Appl. No.: 10/526,745
International Filing Date: 10/29/2003
371(c) Date: 03/07/2005
Examiner: Kallambella M. Vijayakumar
Art Unit: 1793
Confirmation Number: 7863

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated June 19, 2008, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 4 of this document.

Please amend the application as follows: